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	Filing Date		2006-06-19	
	First Named Inventor	Christopher Ausschnitt		
	Art Unit	1756		
	Examiner Name			
	Attorney Docket Number	FIS920020101US1		

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	2	RAYMOND C.J., et al. - "Metrology Of Subwavelength Photoresist Gratings Using Optical Scatterometry" - Journal of Vacuum Science and Technology: Part B 13, AVS/AIP, Melville, New York (US) - Jul/Aug 1995 - 1484-1495	<input type="checkbox"/>

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